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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *None K.N.*\*\* FOREIGN APPLICATIONS \*\*\*\*\* *None K.N.*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 09/14/2001

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	CA	5	20	1
Verified and Acknowledged	<i>K.N.</i> Examiner's Signature / Initials				

## ADDRESS

32588

## TITLE

Selective etching of organosilicate films over silicon oxide stop etch layers

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